

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of

Mutsumi KIMURA

Application No.: 10/765,200

Filed: January 28, 2004

Docket No.: 118319

For: METHOD OF MANUFACTURING THIN FILM ELEMENT, THIN FILM TRANSISTOR
CIRCUIT SUBSTRATE, ACTIVE MATRIX DISPLAY DEVICE, ELECTRO-OPTICAL
DEVICE, AND ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

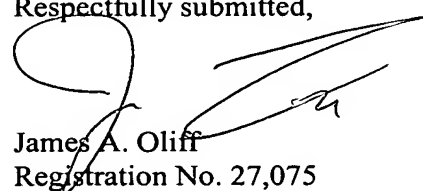
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in a counterpart foreign application.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 4. Reference 1 corresponds to Reference 3. Reference 2 corresponds with Reference 4.

Respectfully submitted,


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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118319		APPLICATION NO. 10/765,200	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Mutsumi KIMURA			
				FILING DATE January 28, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1.	6,521,511	02/18/2003	Satoshi INOUE et al.			
	2.	6,372,608	04/16/2002	Tatsuya SHIMODA et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	3.	TW 382820	02/21/2000	TAIWAN, R.O.C.			
	4.	TW 360901	06/11/1999	TAIWAN, R.O.C.			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: February 1, 2005